The Laboratory

The Institute of Electronics, Microelectronics and Nanotechnology (IEMN) was founded in 1992 with the support of three regional partners: The University of Lille, the University of Valenciennes and Hainaut Cambrésis, ISEN-Lille together with the CNRS (National Center for Scientific Research) which is a government-funded research organization, under the administrative authority of France's Ministry of Higher Education and Research.

The main objective at the time was to gather together in a single research structure disciplines contributing to the progress of microelectronics, MEMS, optics and acoustics and their various applications. Such an organization naturally facilitates interdisciplinary research over a wide spectrum of activities ranging from theoretical physics to telecommunications. Twenty years on, IEMN has increased in scope to encompass nanoelectronics, nanotechnologies and nanosciences. In this period, IEMN has doubled its staff and its budget is four times higher than at its creation and we can claim that the original objectives are fulfilled

Today, nearly 500 people work together in scientific fields ranging from information and communication technologies to micro and nano technologies. The staff is evenly distributed among permanent and nonpermanent employees. The contribution of IEMN to higher education is very important; through doctoral and masters programs which encompass around 160 PhD students and 30 master

The scientific policy of the laboratory is determined within 20 research groups and emerging activities. This is promoted by 5 research departments:

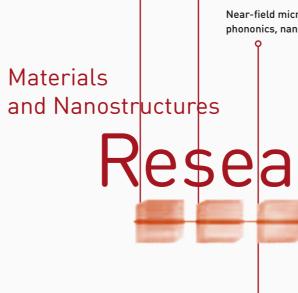
- Materials and nanostructures
- Micro and nano-systems
- Micro nano and optoelectronics
- Circuits and communication systems
- Acoustics

Medium-term joint programs with industrial partners or other national institutions and long-term research initiatives stimulate the resourcing of our research projects. Due to the constant financial support of the Nord Pas de Calais Regional Council combined with those of our trustees, IEMN can boast exceptional technical facilities:

- Micro and nano fabrication cleanroom (1600m²)
- Very high frequency and MEMS characterization platform
- Near-field microscopy platform (AFM/STM)
- Telecommunication platform

As a member of the French Basic Technological Research Network in micro and nano fabrication, IEMN offers to academic and industrial partners access to technical infrastructure ranking among the best in Europe. In addition to its exceptional equipment, IEMN provides to its partners an outstanding expertise on processes based upon 20 years of experience.

Our scientific policy not only contributes to stimulating exceptional scientific research and its applications but also has the goal of bringing social, cultural and economic benefits for society through our many collaborations with industry.



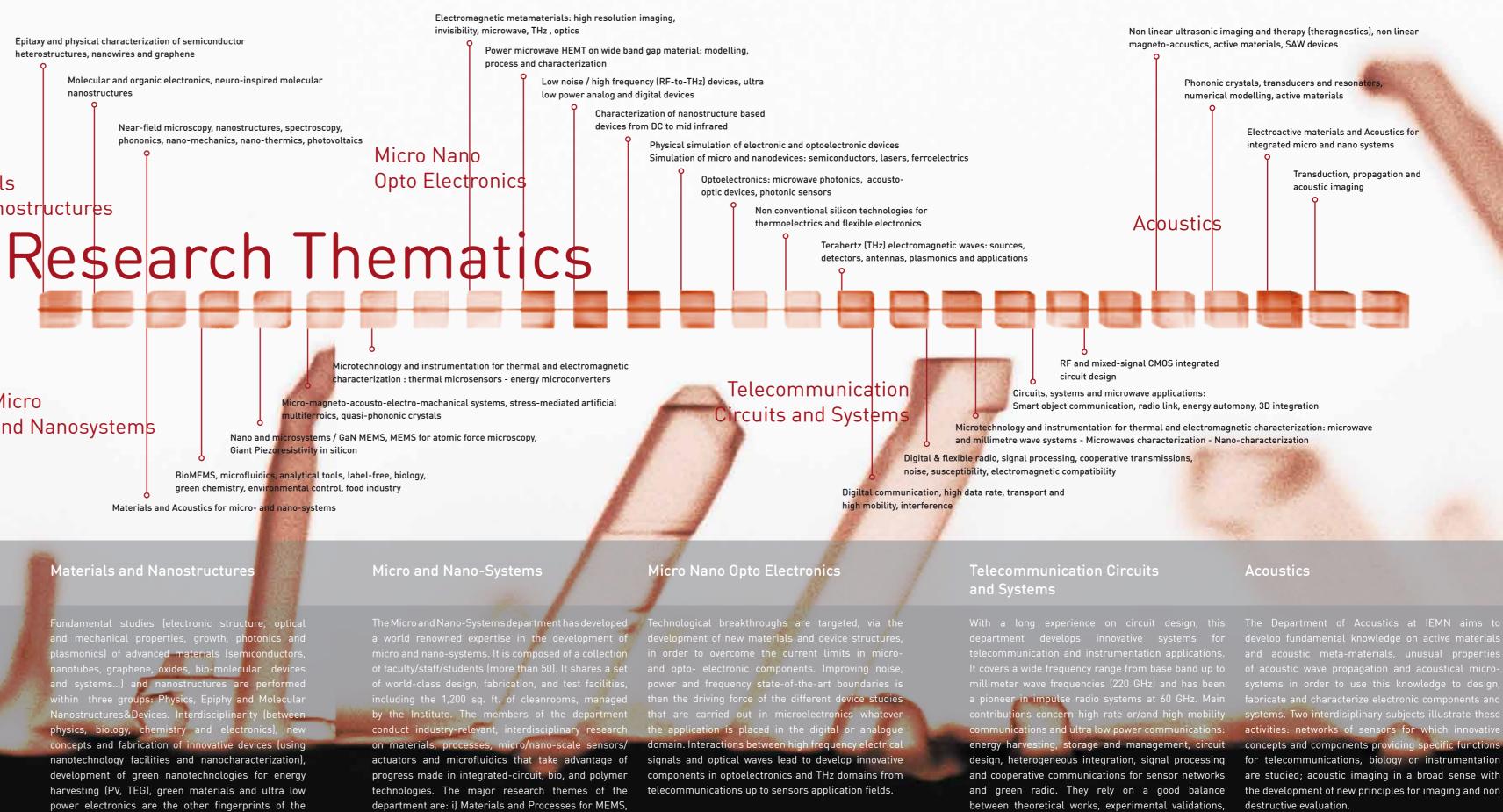
nanostructures

Micro and Nanosystems

ii) Actuators and Power MEMS, iii) Biological MEMS.

aterials and Nanostructure

oncepts and fabrication of nanotechnology facilities and nanocharacterization), development of green nanotechnologies for energy harvesting (PV, TEG), green materials and ultra low power electronics are the other fingerprints of the department.



demonstrations and realizations.



Cité Scientif . Avenue Poincaré BP 60069

Cité Scientifique, Bât P3 59655 Villeneuve d'Ascq Cedex - FRANCE

59313 Valenciennes Cedex 9 - FRANCE Fax: +33 (0)3 27 51 11 89

CMFS Université Lille1 Sciences et Technologies Université Sciences ISEN école de Valenciennes et du Hainaut-Cambrésis ISEN école

IEMN - Antenne ISEN 41, Boulevard Vauban 59046 Lille Cedex - FRANC Phone: +33 (0)3 20 30 40 50 Fax: +33 (0)3 20 30 40 51



FRENCH PROGRAM 'INVESTISSEMENT D'AVENIR' - EQUIPEX

- **O ExCELSIOR** gathers new and unique equipments in Europe for nanodevices characterization. ExCELSiOR is also a project of shared resources characterization center for nanosciences operating in open access for the scientific and industrial communities.
- **O LEAF** project proposes to introduce innovative processing techniques based on laser photothermal ablation for heterogeneous integration and interconnect of high-performance device/ circuit/microsystems on a flexible substrate. It is backed up by a consistent research program with distinctive focused objectives: the development multi-Ghz flexible electronics and the integration of highly heterogeneous functional materials.

Micro and

Staff: 26 Engineers/Tech Equipment: about 20 M€



- material, graphene
- Functionalization
- chemical etch

- Device Assembly : wire bonding,
- dicing , thinning and polishing

NanoFabrication clean-room

1,200 sq. ft. of clean room devoted to micro and nanotechnology

Measurement **NanoFabrication** clean-room

Staff: 5 Engineers Equipment: 3,5 M€

Scanning Probe Microscopy Platform

Staff: 3 Engineers Equipment: 3,3 M€

Telecom Platform

Staff: 3 Engineers/Tech Equipment: 2,5 M€







Technological Facilities

As part of the national Network of Large Technological Facilities and Basic Technological Research (BTR), IEMN Nanolab facilities missions are to support academic organizations and industries that aim international research level in micro and nanotechnology.

 Molecular Beam Epitaxy : III/V Ion Implantation : more than 30 elements implantable Organic Chemistry and Surface • Lithography : Front side and backside alignment, electronic direct writing with pixel size of 1.25 nm. • Etch : ICP and DRIE dry etch tool, wet Deposition : PVD, PECVD, ALD, LPCVD • Electroplating (Au, Cu) Characterization : SEM and FIB, physical and electrical characterization

Devoted to carry out a full electrical and microwave characterization in a wide temperature range of high speed components such as passive devices (antennas and MEMS) and active devices (HBT, HEMT, MOSFET...)

- 30 kHz-500GHz network analyzers • DC and Microwave cryogenic probe station (67GHz-5K)
- High temperature probe station (50GHz-600K)
- Microscopic temperature mapping system using Infra-Red camera Noise measurements up to 220GHz
- Non linear measurements up to 110GHz with loadpull setup HIROX microscope for optical
- inspection Vacuum probe station
- Laser vibrometer instrument • THz measurements using electrooptic sampling Microwave photonics probe station
- Scanning Microwave Atomic Force Microscope Solar simulator

• The Scanning probe microscopy platform brings to the scientist the capacity to observe atoms from material surface and nanometric objects with a 3 dimensional sight This "nanoprobe" also access to local physical characteristics of materials and nanostructures

- The platform includes 8 microscopes working in ambient or high vacuum condition and cryogenic temperature The different probes available interact
- with the sample thanks to tunneling current or atomic force These microscopes are usually based on only one probe but our last new equipment includes 4 probes and a scanning electron microscope, this setup allows nanoscale localization and transport measurement of 1D

and 2D nanostructures

This unique academic platform in Europe offers a large set of advanced scientific equipments for the development of new radio modules and communication systems, up to the millimeter wave range. It is particularly suited for wireless ad hoc or mixed radio-fiber networks for smart objects and sensors, towards an ambient intelligence.

Generation of complex analog, digital

- or mixed signals of analog, digital or mixed signals and MIMO analysis

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Institute of Electronics, Microelectronics